



IPW/14

PATENT
DOCKET NO.: 11809/27

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS : G. Carey et al.
SERIAL NO. : 10/735,695
FILED : December 16, 2003
FOR : METHOD OF FABRICATION OF A SUPPORT
STRUCTURE FOR SEMICONDUCTOR DEVICE
GROUP ART UNIT : 2813
EXAMINER : Yennhu V. Huynh

HON. COMMISSIONER
FOR PATENTS
P.O. Box 1450
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RESPONSE TO RESTRICTION REQUIREMENT

S I R:

The following remarks are respectfully submitted in response to the Office Action dated
December 14, 2004.

A listing of the claims begins on page 2.

Remarks begin on page 7.